



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaki Aoki et al.

Serial No.: 09/997,988

Filed: 11.29.2001

For: METHOD OF PRODUCING  
PLASMA DISPLAY PANEL WITH  
PROTECTIVE LAYER OF AN  
ALKALINE EARTH OXIDE

Patent Examiner: Kunemund, Robert M.

Group Art Unit: 1765

September 1, 2004

Irvine, California 92614

**SUPPLEMENTAL  
INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, Applicant wishes to bring to the attention of the U.S. Patent Office the following references:

IBM Technical Disclosure Bulletin Vol. 18, No. 6, November 1975, article entitled FABRICATION PROCESS FOR GAS DISCHARGE PANELS

Article entitled EPITAXIAL GROWTH, Part A edited by J.W. Matthews

Article entitled THIN FILM PROCESSES edited by Vossen & Kern

Copies of these references and form PTO-A820 are attached.

Please charge the \$180.00 fee for submission of this Information Disclosure Statement to our Deposit Account No. 19-2814, a copy of this letter is enclosed for that purpose.

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If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patent, PO Box 1450, Alexandria, VA 22313-1450 on September 1, 2004

by: James Lee

  
\_\_\_\_\_  
Signature

Date of Signature: September 1, 2004

Very truly yours,

SNELL & WILMER LLP

  
\_\_\_\_\_  
Joseph W. Price, Esq.

Reg. No. 25,124

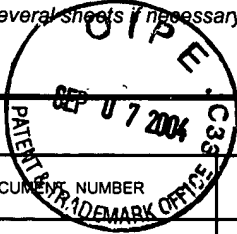
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# **INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)



ATTY DOCKET NO.

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APPLICANT(S)

Masaki Aoki et al.

FILING DATE

November 29, 2001

GROUP

1765

## **U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## **FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

## **OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

		IBM Technical Disclosure Bulletin, FABRICATION PROCESS FOR GAS DISCHARGE PANELS by M. Berkenblit et al., Vol. 18, No. 6, November 1975, 2 pages
		EPITAXIAL GROWTH, Part A, edited by JW Matthews, IBM Thomas J. Watson Research Center, New York, Pages 91-99
		THIN FILM PROCESSES, Edited by John L. Vossen and Werner Kern, RCA Laboratories, David Sarnoff Research Center, New Jersey, 1978, Pages 340-341

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.